

LASER-INDUCED DAMAGE THRESHOLD (LIDT) MEASUREMENT REPORT

S-ON-1 (ISO 21254-2) TEST PROCEDURE

SAMPLE: M0075645 LOT0058860 SU012564

Request from	
Address	Altechna Mokslininku st. 6A 08412 Vilnius Lithuania
Contact person	Aurelija Vasiljeva
Testing institute	
Address Tester Test date Sale order Test ID	UAB Lidaris Saulėtekio al. 10 10223 Vilnius Lithuania Egidijus Pupka 2020-01-15 SO1618 KGXQNE
Specimen	
Name	M0075645 LOT0058860 SU012564
Туре	PR Coating (PR (R=75±2%) @ 2075-2105 (centered @ 2090 nm))
Packaging	Membrane box



TEST EQUIPMENT

Test setup



Laser and its parameters

Q-switched, seeded Nd:YAG Type Manufacturer InnoLas Laser II Model SpitLight Hybrid with OPO Central wavelength 2090.0 nm Angle of incidence 0.0 deg Polarization state Linear Pulse repetition frequency 100 Hz Spatial beam profile in target plane Near Gaussian Beam diameter in target plane $(1/e^2)$ $(181.9 \pm 5.9) \, \mu m$ Longitudinal pulse profile Single longitudinal mode Pulse duration (FWHM) (4.3 ± 0.3) ns Pulse to pulse energy stability (SD) 4.5 %

Energy/power meter

Manufacturer Model Calibration due date





Figure 1. Laser parameters used for measurements.



TEST SPECIFICATION

Definitions and test description

Laser-induced damage (LID) is defined as any permanent laser radiation induced change in the characteristics of the surface/bulk of the specimen which can be observed by an inspection technique and at a sensitivity related to the intended operation of the product concerned. Laser-induced damage threshold (LIDT) is defined as the highest quantity of laser radiation incident upon the optical component for which the extrapolated probability of damage is zero. ¹

LID of the sample is investigated by performing a standardized S-on-1 test procedure.² LIDT value is determined by fitting experimental damage probability data with a model derived for a Poisson damage process assuming degenerate defect ensemble. ³

Test sites	
Number of sites	209
Arrangement of sites	Hexagonal
Minimum distance between sites	600 μm
Maximum pulses per site	1000
Damage detection	
Online	Scattered light diode
Offline	Nomarski microscope
Test environment	
Environment	Air
Cleanroom class (ISO 14644-1)	ISO7
Pressure	1 bar
Temperature	23 C
Humidity	25 %
Sample preparation	
Storage before test	Normal laboratory conditions
Dust blow-off	None
Cleaning	None

¹ISO 21254-1:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 1: Definitions and general principles, International Organization for Standardization, Geneva, Switzerland (2011)

²ISO 21254-2:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 2: Threshold determination, International Organization for Standardization, Geneva, Switzerland (2011)

³J. Porteus and S. Seitel, Absolute onset of optical surface damage using distributed defect ensembles, Applied Optics, 23(21), 3796–3805 (1984)



LIDT TEST RESULTS

LIDT VALUES

Table 1: Estimated LIDTs from fiting model for sample M0075645 LOT0058860 SU012564.

Test mode	Threshold (Offline detection - microscopy) ⁴	Threshold (Offline detection - microscopy) scaled to 10 ns
10 ³ -on-1	$> 24.2 + 4.0 \ \text{J/cm}^2$	$> 36.7 + 6.0 \ \text{J/cm}^2$

DAMAGE PROBABILITY



Figure 2. Damage probability plot.



TECHNICAL NOTES

TECHNICAL NOTE 1: No damages were found

No damages were found for this type of analysis, therefore, LIDT value could not be evaluated. LIDT value should be higher than maximum fluence value used in the test. This fluence value is written in the thresholds table.